IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Setsuo NAKAJIMA	)	
		Group Art Unit: 2814
Application No. 10/752,993	)	
Filed: January 8, 2005	)	Confirmation No.: 6484
Title: METHOD FOR MANUFACTURING A SEMICONDUCTOR DEVICE	)	

CORRECTED INFORMATION DISCLOSURE STATEMENT

United States Patent and Trademark Office
Customer Window
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

Applicant noted errors in the PTO Form-1449 that was filed August 28, 2009. Specifically, the Publication Year for "PHYSICS OF SEMICONDUCTOR DEVICES" was incorrect and should be January 1, 1981.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned. In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, the accompanying information is being submitted in accordance with 37 C.F.R. §§1.97 and 1.98.

Respectfully submitted,

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